



Socket No.: 50099-180

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Shigenobu MAEDA, et al.

Application No.: 09/988,593

Filed: November 20, 2001

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Group Art Unit: 2823

Examiner: T. Pham

For: SEMICONDUCTOR DEVICE HAVING IMPURITY REGION UNDER ISOLATION  
REGION (As amended)

#8/a  
3/14/13  
Surber

**AMENDMENT**

Box Non-Fee Amendment  
The Commissioner for Patents and Trademarks  
Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Office Action  
dated December 13, 2002. Please amend the above-identified application as follows:

**IN THE TITLE:**

Please replace "SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING  
THE SAME" with --SEMICONDUCTOR DEVICE HAVING IMPURITY REGION UNDER  
ISOLATION REGION--.

**IN THE SPECIFICATION:**

Please delete the first two full paragraphs in page 21 in their entirety and replace with the  
following:

RECEIVED  
MAR 12 2003  
TECHNOLOGY CENTER 2800